

Amendments to the Abstract

Please amend the original abstract (page 184) as follows.

ABSTRACT OF THE DISCLOSURE

~~The present invention relates to a~~ A revolution member supporting apparatus holds and rotates ~~for holding and rotating~~ a disc-shaped object (object to be rotated) such as a semiconductor wafer. The ~~A~~ revolution member supporting apparatus includes, comprising: a rotatable member which rotates about an axis of ~~rotation;~~ rotation, and a plurality of holding members which are disposed along a circle having a center corresponding to the axis of rotation of the rotatable member, and which revolve around the axis of rotation when the rotatable member ~~rotates;~~ rotates, wherein the holding members are allowed to swing about their own central axes.